

# Broad-Band Simultaneous Measurement of Complex Permittivity and Permeability Using a Coaxial Discontinuity

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**Abstract**—A technique is presented for simultaneously measuring the real and imaginary parts of both permittivity and permeability of a given material. A gap in a coaxial line is filled with the material under test. Complex permittivity and permeability are computed from the  $S$ -parameter ( $S_{11}$  and  $S_{21}$ ) measurement made on the gap taking into account higher order modes excited at the discontinuity. Measured  $\epsilon_r$  and  $\mu_r$  data for several materials are presented from 45 MHz up to 18 GHz. This technique shows good agreement between calculated and generally accepted values.

## I. INTRODUCTION

NUMEROUS MEASURING methods applicable to ranges of values for permittivity and permeability and to different frequency bands have been developed by the American Society for Testing and Materials and by various authors [1]–[3]. With the advent of automated vector network analyzers and calculators, broad-band measurements have been developed. Weir [4] uses complex reflection and transmission coefficients presented when a sample of material to be tested is inserted into a waveguide or a transmission line propagating the TEM mode. This method, adopted by Barry [5] in stripline technology, is nevertheless limited in frequency. The increase in frequency in fact is limited by the appearance of resonance phenomena due to the size of the sample and to the presence of higher order modes which are not taken into account in the theoretical formulation of the problem. The method wherein a precision air line is filled with a test specimen is unusual for relatively high  $\epsilon'$  and  $\mu'$  ( $> 20$ ) and high frequencies. Sucher [3] shows that air gap errors near inner and outer conductors become increasingly serious with increasing dielectric constant. In the measurement of ceramics in an APC7-mm precision air line ( $\epsilon' = 10$ ), for example, the measured  $\epsilon'$  is about 4.7 for dimensional tolerances of  $\pm 0.01$  mm.

The solution presented here uses an inner coaxial conductor discontinuity into which the sample to be measured is easily inserted. The electromagnetic analysis of the structure (direct problem) is valid irrespective of the size of the

sample and the working frequency. The uncertainty due to an error in sample dimensions is not a main factor for this method. For this study we used “mode matching,” the same method used previously [6] to define the different modes excited by the discontinuity. The calculation of  $\epsilon_r$  and  $\mu_r$  from  $S_{11}$  and  $S_{21}$  measurements (inverse problem) is linked to two infinite systems of simultaneous equations. We demonstrate that this problem is reduced to two systems, each containing three equations with three unknowns. Computer time is therefore reasonable without affecting accuracy.

## II. DIRECT PROBLEM

### A. Formulation of the Problem

We examine the structure shown in Fig. 1. The interruption of the inner conductor of the coaxial line constitutes a circular waveguide filled with a homogeneous and isotropic material. The sample, of thickness  $2d$ , shows complex permittivity and permeability:

$$\epsilon_r = \epsilon' - j\epsilon'' \quad (1)$$

$$\mu_r = \mu' - j\mu'' \quad (2)$$

The coaxial line is much longer than the transverse dimensions. It is filled with air and propagates the TEM mode only. Moreover the conductors are assumed to be perfect.

At planes  $T1$  and  $T2$  (the air-material interfaces) the sample can be represented as a quadrupole characterized by its  $[Y]$  and  $[S]$  matrices [1]. The admittances are normalized in relation to the characteristic admittance of the coaxial line. Given that the structure is symmetrical, the representations used are also symmetrical (Fig. 1). In this case the relationships between the elements of the admittance matrix and those of the scattering matrix are easily obtained:

$$S_{11} = S_{22} = \frac{1 - y_{11}(y_{11} + 2y_{12})}{(1 + y_{11})(1 + y_{11} + 2y_{12})} \quad (3)$$

$$S_{21} = S_{12} = \frac{2y_{12}}{(1 + y_{11})(1 + y_{11} + 2y_{12})} \quad (4)$$

Let us apply the bisection theorem to the sample and to the quadrupole. In the presence of an electric wall placed

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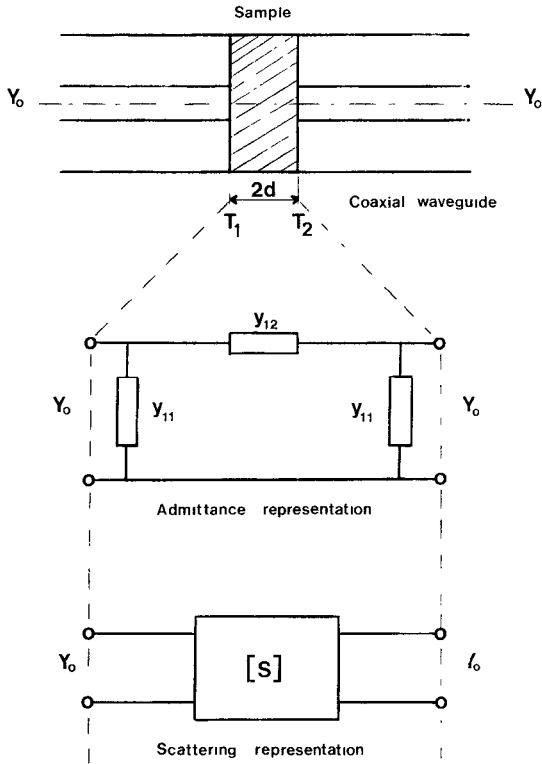


Fig. 1. Geometry of the structure and equivalent representations.

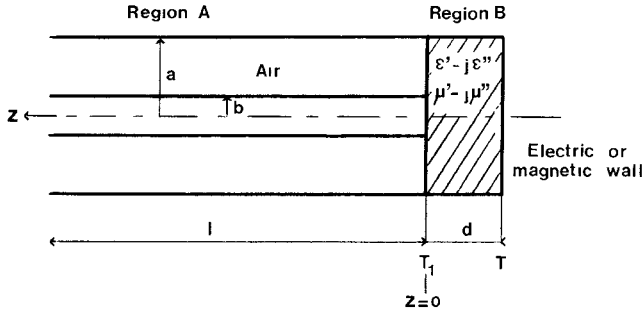


Fig. 2. Representation of the bisected structure.

at plane  $T$ , the normalized input admittance at plane  $T1$  is

$$y_e = y_{11} + 2y_{12}. \quad (5)$$

If a magnetic wall is next placed at plane  $T$ , the input admittance is

$$y_m = y_{11}. \quad (6)$$

As a result, (3) and (4) can be written

$$S_{11} = S_{22} = \frac{1 - y_m y_e}{(1 + y_m)(1 + y_e)} \quad (7)$$

$$S_{21} = S_{12} = \frac{y_e - y_m}{(1 + y_m)(1 + y_e)}. \quad (8)$$

Equations (7) and (8) enable us to link the measurements of the  $S$  parameters to the electric and magnetic properties of the material placed in the cell. To calculate the input impedances  $y_e$  and  $y_m$  we used the same electromagnetic analysis as before [6].

Let us consider a TEM wave propagating in region  $A$  of Fig. 2. The cylindrical symmetry enables us to predict that only  $E$  modes independent of the azimuthal angle  $\phi$  will be excited at the  $z = 0$  plane. To be unhampered by the line excitation method, we take a length of coaxial line which is much longer than the transverse dimensions so that the higher order modes created by the source are not superposed on the higher order modes excited by the discontinuity.

In the air-filled region  $A$ , the components of the total electromagnetic field are

$$E_{rA} = \frac{1}{r} A_0 (\exp + jk_0 z + \Gamma \exp - jk_0 z) + \sum_{q=1}^{\infty} A_q Z_1(\xi_q r) \exp \gamma_q z \quad (9)$$

$$E_{zA} = \sum_{q=1}^{\infty} A_q \frac{\xi_q}{\gamma_q} Z_0(\xi_q r) \exp - \gamma_q z \quad (10)$$

$$H_{\phi A} = \frac{1}{r} A_0 Y_{A0} (\exp + jk_0 z - \Gamma \exp - jk_0 z) + \sum_{q=1}^{\infty} A_q Y_{Aq} Z_1(\xi_q r) \exp - \gamma_q z \quad (11)$$

where  $A_0$  represents the incident TEM wave amplitude and  $\Gamma$  its reflection coefficient at plane  $T1$  of the discontinuity;  $Y_{A0}$  and  $Y_{Aq}$  are respectively the wave admittances of the TEM mode and the higher order mode  $E_{0q}$  in the coaxial waveguide:

$$Y_{A0} = -\sqrt{\frac{\epsilon_0}{\mu_0}} \quad (12)$$

$$Y_{Aq} = \frac{j\omega\epsilon_0}{\gamma_q} \quad (13)$$

with

$$k_0 = \omega\sqrt{\epsilon_0\mu_0} \quad (14)$$

and

$$\gamma_q = \sqrt{\xi_q^2 - k_0^2}. \quad (15)$$

In (9), (10), and (11),  $Z_p$  denotes the linear combination of the  $p$ th-order Bessel functions of the first and second kinds as follows:

$$Z_p(\xi_q r) = J_p(\xi_q r) + G_{Aq} N_p(\xi_q r) \quad \text{with } p = 0 \text{ or } 1. \quad (16)$$

When an electric wall is placed at plane  $T$ , the electric field boundary conditions at this plane provide the solutions for region  $B$ :

$$E_{rB} = \sum_{i=1}^{\infty} B'_i J_1(\lambda_i r) \text{sh } \gamma_i(z + d) \quad (17)$$

$$E_{zB} = \sum_{i=1}^{\infty} B'_i \frac{\lambda_i}{\gamma_i} J_0(\lambda_i r) \text{ch } \gamma_i(z + d) \quad (18)$$

$$H_{\phi B} = \sum_{i=1}^{\infty} -\frac{j\omega\epsilon_0\epsilon_r}{\gamma_i} B'_i J_1(\lambda_i r) \text{ch } \gamma_i(z + d). \quad (19)$$

with

$$\gamma_i = \sqrt{\lambda_i^2 - k^2} \quad (20)$$

and

$$k^2 = k_0^2 \epsilon_r \mu_r. \quad (21)$$

The axial component  $E_z$  for the electric field for each  $E$  wave must be zero at the conductors in the two regions. The following conditions are thus obtained:

$$Z_0(\xi_q a) = Z_0(\xi_q b) = 0 \quad (22)$$

$$J_0(\lambda_i a) = 0. \quad (23)$$

Relation (22) enables us to determine the coefficient  $G_{Aq}$  contained in (16):

$$G_{Aq} = -\frac{J_0(\xi_q a)}{N_0(\xi_q a)} = -\frac{J_0(\xi_q b)}{N_0(\xi_q b)} \quad (24)$$

and thus from the transcendental equation (25), the coefficient  $\xi_q$ :

$$J_0(\xi_q a) N_0(\xi_q b) - J_0(\xi_q b) N_0(\xi_q a) = 0. \quad (25)$$

The matching conditions for the transverse components at the plane  $T_1$  are expressed in the following manner:

$$E_{rB} = 0, \quad 0 < r < b \quad (26)$$

$$E_{rB} = \sum_{i=1}^{\infty} B_i J_1(\lambda_i r) = \frac{1}{r} A_0 (1 + \Gamma) + \sum_{q=1}^{\infty} A_q Z_1(\xi_q r), \quad b < r < a \quad (27)$$

$$H_{\phi B} = \sum_{i=1}^{\infty} B_i Y_{ei} J_1(\lambda_i r) = \frac{1}{r} A_0 Y_{A0} (1 - \Gamma) + \sum_{q=1}^{\infty} A_q Y_{Aq} Z_1(\xi_q r), \quad b < r < a \quad (28)$$

where

$$B_i = B'_i \text{sh } \gamma_i d \quad (29)$$

and

$$Y_{ei} = \frac{-j\omega\epsilon_0\epsilon_r}{(\lambda_i^2 - k^2)^{1/2}} \coth(\sqrt{\lambda_i^2 - k^2} d). \quad (30)$$

Coefficients  $A_q$  and  $B_i$  are determined by using the orthogonality properties of Bessel functions. The first step is to perform the following integral:

$$\int_0^a r J_1(\lambda_s r) E_{rB} dr. \quad (31)$$

Using Lommel integrals and equalities (26), (27), (22), and (23), we obtain

$$\frac{B_i}{\lambda_i} = A_0 (1 + \Gamma) \frac{2J_0(\lambda_i b)}{\lambda_i^2 a^2 J_1^2(\lambda_i a)} \cdot \left( 1 - \sum_{q=1}^{\infty} \frac{A_q}{A_0 (1 + \Gamma)} \cdot \frac{bZ_1(\xi_q b)}{\xi_q^2 / \lambda_i^2 - 1} \right). \quad (32)$$

Next,  $H_{\phi B}$  is integrated over the range  $b < r < a$ . Relations (28), (22), and (23) give

$$Y_{A0} A_0 (1 - \Gamma) \ln \frac{a}{b} = \sum_{i=1}^{\infty} \frac{B_i Y_{ei}}{\lambda_i} J_0(\lambda_i b). \quad (33)$$

The last step is to integrate the quantity  $rZ_1(\xi_n r)H_{\phi B}$  over the range  $b < r < a$ . Hence

$$\frac{Y_{An}}{2} A_n b Z_1(\xi_n b) \left[ \frac{a^2 Z_1^2(\xi_n a)}{b^2 Z_1^2(\xi_n b)} - 1 \right] = \sum_{i=1}^{\infty} \frac{B_i Y_{ei} \lambda_i J_0(\lambda_i b)}{\lambda_i^2 - \xi_n^2}. \quad (34)$$

The normalized input admittance  $y_e$  in the plane  $T_1$  may be written in the following form:  $\frac{1 - \Gamma}{1 + \Gamma}$ . Equations (32) and (33) allow us derive the solution:

$$y_e = j \frac{2k_0 a \epsilon_r}{\ln \frac{a}{b}} \sum_{i=1}^{\infty} \frac{J_0^2(\lambda_i b) \coth \left[ (\lambda_i^2 a^2 - k^2 a^2)^{1/2} d/a \right]}{(\lambda_i^2 a^2 - k^2 a^2)^{1/2} \lambda_i^2 a^2 J_1^2(\lambda_i a)} \cdot \left( 1 - \sum_{q=1}^{\infty} \frac{A_q}{A_0 (1 + \Gamma)} \cdot \frac{bZ_1(\xi_q b)}{\xi_q^2 / \lambda_i^2 - 1} \right). \quad (35)$$

or, alternatively,

$$y_e = j \frac{2k_0 a \epsilon_r}{\ln \frac{a}{b}} \left( y_0 - \sum_{q=1}^{\infty} y_q x_q \right) \quad (36)$$

assuming that

$$y_0 = \sum_{i=1}^{\infty} \frac{\coth \left[ (\lambda_i^2 a^2 - k^2 a^2)^{1/2} d/a \right]}{(\lambda_i^2 a^2 - k^2 a^2)^{1/2} \lambda_i^2 a^2} \cdot \frac{J_0^2(\lambda_i b)}{J_1^2(\lambda_i a)} \quad (37)$$

$$x_q = \frac{A_q}{A_0 (1 + \Gamma)} \cdot bZ_1(\xi_q b) \quad (38)$$

$$y_q = - \sum_{i=1}^{\infty} \frac{\coth \left[ (\lambda_i^2 a^2 - k^2 a^2)^{1/2} d/a \right]}{(\lambda_i^2 a^2 - k^2 a^2)^{1/2} (\lambda_i^2 a^2 - \xi_q^2 a^2)} \cdot \frac{J_0^2(\lambda_i b)}{J_1^2(\lambda_i a)}. \quad (39)$$

The coefficients  $x_q$  are obtained from (34) using relations

(32), (30), and (13). This leads to the matrix equation

$$\begin{aligned} & \frac{1}{\epsilon_r} \cdot \frac{x_n}{4(\xi_n^2 a^2 - k_0^2 a^2)^{1/2}} \left[ \frac{a^2 Z_1^2(\xi_n a)}{b^2 Z_1^2(\xi_n b)} - 1 \right] \\ &= \sum_{i=1}^{\infty} - \frac{\coth \left[ (\lambda_i^2 a^2 - k^2 a^2)^{1/2} d/a \right]}{(\lambda_i^2 a^2 - k^2 a^2)^{1/2} (\lambda_i^2 a^2 - \xi_n^2 a^2)} \cdot \frac{J_0^2(\lambda_i b)}{J_1^2(\lambda_i a)} \\ & - \sum_{i=1}^{\infty} \sum_{q=1}^{\infty} x_q \frac{\lambda_i^2 a^2 \coth \left[ (\lambda_i^2 a^2 - k^2 a^2)^{1/2} d/a \right]}{(\lambda_i^2 a^2 - k^2 a^2)^{1/2} (\lambda_i^2 a^2 - \xi_q^2 a^2) (\lambda_i^2 a^2 - \xi_n^2 a^2)} \cdot \frac{J_0^2(\lambda_i b)}{J_1^2(\lambda_i a)} \end{aligned} \quad (40)$$

or

$$\sum_{q=1}^{\infty} A_{qn} x_q = y_n, \quad n=1, 2, \dots \quad (41)$$

assuming that

$$\begin{aligned} A_{qn} = & \sum_{i=1}^{\infty} \frac{\lambda_i^2 a^2 \coth \left[ (\lambda_i^2 a^2 - k^2 a^2)^{1/2} d/a \right]}{(\lambda_i^2 a^2 - k^2 a^2)^{1/2} (\lambda_i^2 a^2 - \xi_q^2 a^2) (\lambda_i^2 a^2 - \xi_n^2 a^2)} \\ & \cdot \frac{J_0^2(\lambda_i b)}{J_1^2(\lambda_i a)} + \frac{1}{\epsilon_r} \frac{\delta_{qn}}{4(\xi_n^2 a^2 - k_0^2 a^2)^{1/2}} \left[ \frac{a^2 Z_1^2(\xi_n a)}{b^2 Z_1^2(\xi_n b)} - 1 \right] \end{aligned} \quad (42)$$

where  $\delta_{qn}$  is the Kronecker symbol.

If a magnetic wall is placed in the bisection plane  $T$ , the total electromagnetic field in region  $B$  is

$$E_{rB} = \sum_{i=1}^{\infty} B_i'' J_1(\lambda_i r) \operatorname{ch} \gamma_i(z+d) \quad (43)$$

$$E_{zB} = \sum_{i=1}^{\infty} B_i'' \frac{\lambda_i}{\gamma_i} J_0(\lambda_i r) \operatorname{sh} \gamma_i(z+d) \quad (44)$$

$$H_{\phi B} = \sum_{i=1}^{\infty} \frac{-j\omega\epsilon_0\epsilon_r}{\gamma_i} B_i'' J_1(\lambda_i r) \operatorname{sh} \gamma_i(z+d). \quad (45)$$

At the reference plane  $T_1$  these components can be written as follows:

$$E_{rB} = \sum_{i=1}^{\infty} B_i J_1(\lambda_i r) \quad (46)$$

$$E_{zB} = \sum_{i=1}^{\infty} B_i \frac{\lambda_i}{\gamma_i} J_0(\lambda_i r) \cdot \operatorname{th} \gamma_i d \quad (47)$$

$$H_{\phi B} = \sum_{i=1}^{\infty} B_i Y_{mi} J_1(\lambda_i r) \quad (48)$$

with

$$B_i = B_i'' \operatorname{ch} \gamma_i d \quad (49)$$

and

$$Y_{mi} = -j \frac{\omega\epsilon_0\epsilon_r}{(\lambda_i^2 - k^2)^{1/2}} \cdot \operatorname{th} \left[ (\lambda_i^2 - k^2)^{1/2} d \right]. \quad (50)$$

Hence the same procedure is adopted to calculate the input admittance  $y_m$ . We find the same results in replacing

$\coth(\ )$  with  $\operatorname{th}(\ )$  in (26) to (42):

$$y_m = j \frac{2k_0 a \epsilon_r}{\ln \frac{a}{b}} \left( y_0' - \sum_{q=1}^{\infty} y_q' x_q' \right). \quad (51)$$

### B. Numerical Computation

The  $S$ -parameter computation starts with the evaluation of quantities  $\lambda_i$  and  $\xi_q$  from a Bessel subroutine. The roots of the transcendental equations (23) and (25) are found by iteration. It can be shown that all these roots ( $\lambda_i$  and  $\xi_q$ ) are real, even in the lossy case (lossy materials in region  $B$ ) and so the arguments of the calculated Bessel functions are real. These functions are programmed in the polynomial approximations from [7] with an absolute accuracy of  $10^{-8}$ . Hence for a given frequency and for a material of known properties, coefficients  $y_0$  and  $y_1$  can be computed in the two cases of electric and magnetic walls if the summation over  $i$  is truncated. In fact, this truncation recurs to retaining a finite number of higher order modes excited by the discontinuity and present in the sample ( $i=1, 2, \dots, I$ ). In the same manner, to compute the coefficient  $A_{qn}$  we retain  $Q$  higher order modes excited in the coaxial waveguide by the discontinuity. Hence (41) is reduced to two systems of  $Q$  equations with  $Q$  unknowns  $x_q$  ( $q=1, 2, \dots, Q$ ). From this,  $y_e$  and  $y_m$  values are obtained. Since the value of  $Q$  governs the number of simultaneous equations to be solved, it is clear that, for a solution of given accuracy, there will be a considerable saving of computer time and storage if the ratio  $I/Q$  is correctly chosen. The effect on the admittance computation accuracy of the number of higher order modes retained has been described in [8]. We show that the accuracy is better than 0.1 percent if we take  $I=2Q=6$ . Investigations on the rate of convergence for different values of  $I$  and  $Q$  used in the mode-matching method have been reported by other authors [9], [10]. These studies show that the convergence rate of the reflection coefficient is improved when the ratio  $I/Q$  corresponds to the ratio of the cross-sectional areas of the waveguides on either side of the junction and that the convergence is sufficient after only three modes in the small waveguide. Hence all our computations are performed with  $I=6$  and  $Q=3$ . An example is depicted in Figs. 3 and 4. Theoretical and measured values of  $S_{11}$  and  $S_{21}$  are presented between 45 MHz and 18 GHz for an APC7 millimeter cell filled with air ( $2d=0.85$  mm).

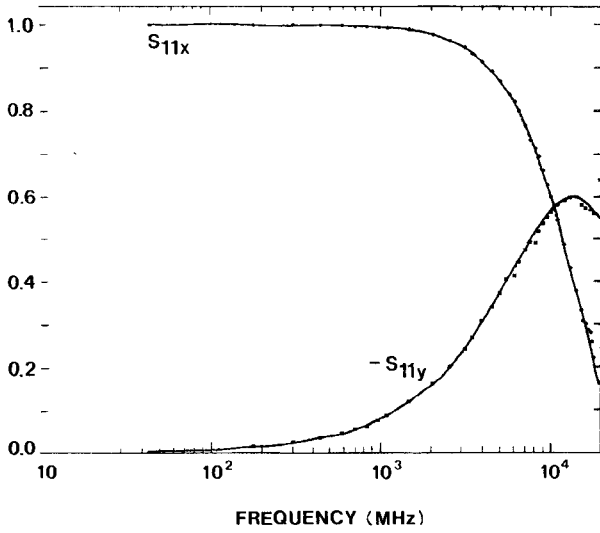


Fig. 3. Real and imaginary parts of the  $S_{11}$  parameter for the gap filled with air in APC7 millimeter coaxial waveguide filled with air;  $2d = 0.85$  mm. (●) Experimental data. ----- Theoretical data.

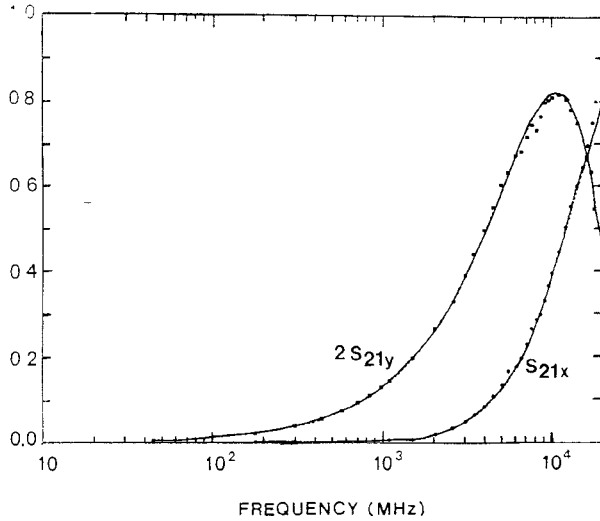


Fig. 4. Real and imaginary parts of the  $S_{21}$  parameter for the gap filled with air in APC7 millimeter coaxial waveguide filled with air;  $2d = 0.85$  mm. (●) Experimental data. ----- Theoretical data.

### III. INVERSE PROBLEM

This section involves the complex permittivity and permeability computation from  $S$ -parameter measurements of the gap filled by the sample. To avoid contact resistances and contact capacitances, the sample is metallized on the contact surfaces with the line conductors. Numerical computations are performed with the HP 9000 series 300 desktop computer.

The simultaneous classification of  $\epsilon_r = \epsilon' - j\epsilon''$  and  $\mu_r = \mu' - j\mu''$  is carried out by comparison between measured and calculated  $S_{11}$  and  $S_{21}$  values. For this purpose we use an iterative method derived from the gradient method. For any initial vector,

$$\vec{C}_0 = \begin{bmatrix} \epsilon' \\ \epsilon'' \\ \mu' \\ \mu'' \end{bmatrix} \quad (52)$$

we define an error vector  $\Delta\vec{S}$  in the following manner:

$$\Delta\vec{S} = \begin{bmatrix} S_{11x}^{(m)} - S_{11x}^{(c)} \\ S_{11y}^{(m)} - S_{11y}^{(c)} \\ S_{21x}^{(m)} - S_{21x}^{(c)} \\ S_{21y}^{(m)} - S_{21y}^{(c)} \end{bmatrix} \quad (53)$$

where the superscripts  $m$  and  $c$  denote respectively the measured and calculated  $S$  parameters in rectangular coordinates. At the  $\Delta\vec{S}$  vector we associated a second vector  $\Delta\vec{C}$  as follows:

$$\Delta\vec{S} = [D]\Delta\vec{C} \quad (54)$$

where the matrix  $[D]$  is defined as the derivative matrix:

$$[D] = \begin{bmatrix} \frac{\partial S_{11x}}{\partial \epsilon'} & \frac{\partial S_{11x}}{\partial \epsilon''} & \frac{\partial S_{11x}}{\partial \mu'} & \frac{\partial S_{11x}}{\partial \mu''} \\ \frac{\partial S_{11y}}{\partial \epsilon'} & \frac{\partial S_{11y}}{\partial \epsilon''} & \frac{\partial S_{11y}}{\partial \mu'} & \frac{\partial S_{11y}}{\partial \mu''} \\ \frac{\partial S_{21x}}{\partial \epsilon'} & \frac{\partial S_{21x}}{\partial \epsilon''} & \frac{\partial S_{21x}}{\partial \mu'} & \frac{\partial S_{21x}}{\partial \mu''} \\ \frac{\partial S_{21y}}{\partial \epsilon'} & \frac{\partial S_{21y}}{\partial \epsilon''} & \frac{\partial S_{21y}}{\partial \mu'} & \frac{\partial S_{21y}}{\partial \mu''} \end{bmatrix} \quad (55)$$

and

$$\Delta\vec{C} = \begin{bmatrix} \Delta\epsilon' \\ \Delta\epsilon'' \\ \Delta\mu' \\ \Delta\mu'' \end{bmatrix} \quad (56)$$

The value of the  $\Delta\vec{C}$  vector is obtained from the inverse matrix  $[D]^{-1}$  as follows:

$$\Delta\vec{C} = [D]^{-1} \cdot \Delta\vec{S} \quad (57)$$

The new direction of investigation is now

$$\vec{C}_n = \vec{C}_{n-1} + \begin{bmatrix} \alpha_1 \Delta\epsilon' \\ \alpha_2 \Delta\epsilon'' \\ \alpha_3 \Delta\mu' \\ \alpha_4 \Delta\mu'' \end{bmatrix} \quad (58)$$

where the  $\alpha_i$  coefficients are equal to 0.8 at maximum. The choice of the coefficients  $\alpha_i$  is performed to give fast convergence. The iterations are stopped when  $\|\Delta\vec{S}\|^2$  is lower than  $10^{-8}$ . This value is fixed by the accuracy of the network analyzer. The calculated  $\epsilon_r$  and  $\mu_r$  values become the initial values for the next measured point. The typical computation time for an experimental frequency point is lower than 1 minute.

### IV. EXPERIMENTAL RESULTS

The results of the measurements on Teflon and alumina are represented in Figs. 5, 6, 7, and 8. The measurements performed on each of these materials were obtained at room temperature using the HP 8510A network analyzer in APC7 millimeter standard. The thickness of the Teflon sample was 4.4 mm, and that of the alumina was 4 mm. These two materials show  $\epsilon'$  values of 2.1 [5] and 9.8 [11]

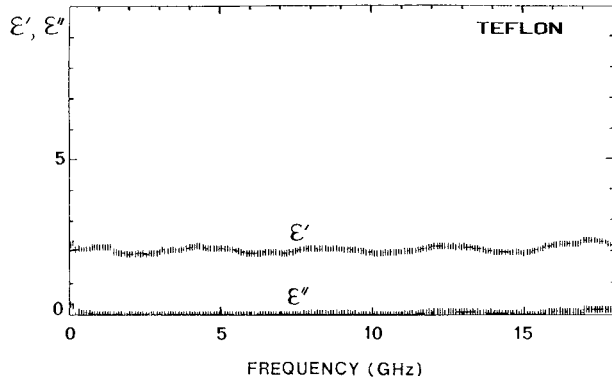


Fig. 5. Complex permittivity measured for a Teflon sample in the 45 MHz–18 GHz frequency range; thickness = 4.4 mm; APC7-mm standard.

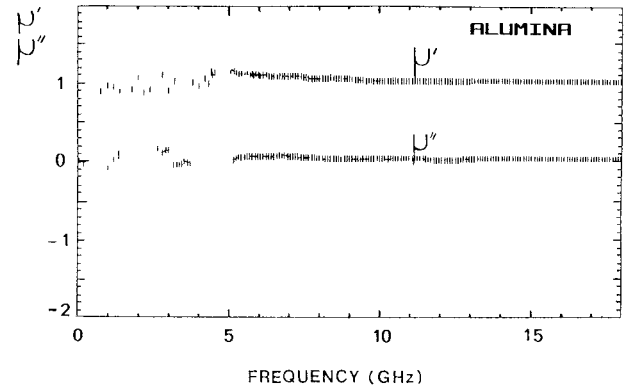


Fig. 8. Complex permeability measured for the alumina sample in the 45 MHz–18 GHz frequency range; thickness = 4 mm; APC7-mm standard.

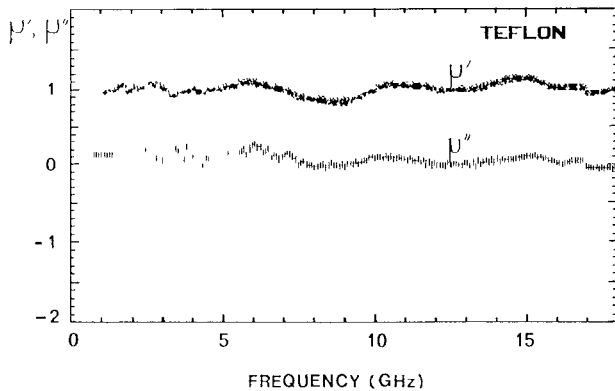


Fig. 6. Complex permeability measured for the Teflon sample in the 45 MHz–18 GHz frequency range; thickness = 4.4 mm; APC7-mm standard.

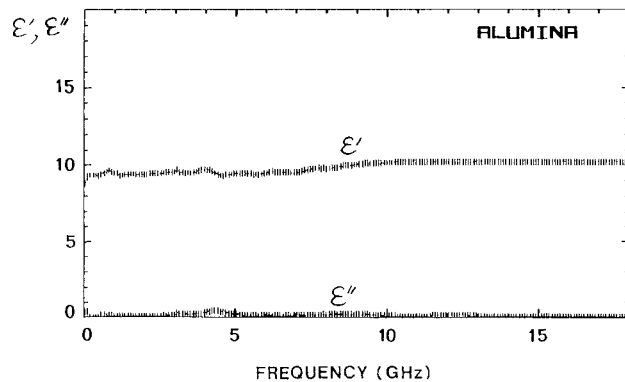


Fig. 7. Complex permittivity measured for an alumina sample in the 45 MHz–18 GHz frequency range; thickness = 4 mm; APC7-mm standard.

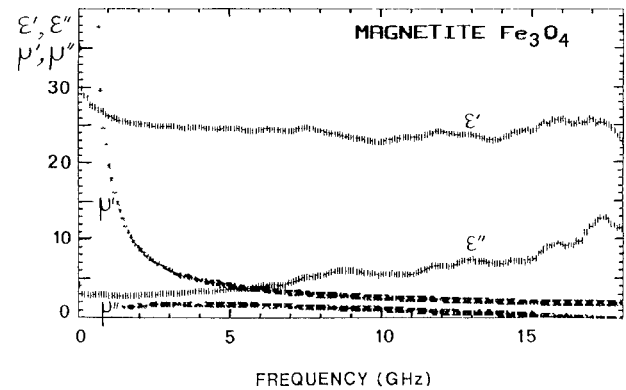


Fig. 9. Complex permittivity and permeability for the magnetite  $\text{Fe}_3\text{O}_4$ . The sample is powder compacted at 3.5 metric tons.

respectively and very low losses ( $\epsilon''$  is lower than 0.0004 for Teflon [2] and than 0.001 for alumina). They are nonmagnetic and have a relative permeability of 1. The values measured, depicted in Figs. 5 to 8, correspond to those anticipated. However, because of the large errors in small  $\epsilon''$  and  $\mu''$ , the measurement of low-loss samples is difficult with this technique. To obtain reasonable accuracy,  $\epsilon''$  and  $\mu''$  should be greater than 0.1. At very low frequencies, the value of  $\mu_r$  for nonmagnetic materials cannot be evaluated with accuracy due to residual mis-

match errors. As one may expect, examination of (35) and (51) shows that  $\mu_r$  is involved in the difference between  $\lambda_1^2 a^2$  and  $k^2 a^2$  only, in contrast to  $\epsilon_r$ , which appears in this difference and as a multiplicative term in (35) and (51). For the very low frequencies,  $k$  is smaller than  $\lambda_1$  and the  $\mu_r$  measurement for nonmagnetic material becomes difficult. The instrumentation errors depend on the magnitudes of  $S_{11}$  and  $S_{21}$ . The magnitude and phase errors for  $S_{11}$  increase when  $|S_{11}|$  approaches zero. The magnitude and phase errors for  $S_{21}$  increase when  $|S_{21}|$  is lower than 0.1. As  $|S_{21}|$  is usually lower than 0.1 for frequencies below 1 GHz, the maximum error for  $\mu_r$  occurs in this band of frequencies. For Teflon and alumina samples, the length is selected to give  $S_{11}$  and  $S_{21}$  of equal magnitudes, which achieves greatest accuracy.

The accuracy of the method was computed by simulation on a calculator. The calculator, programmed for the HP8510A system instrumentation errors, and the measurements of the  $S_{11}$  and  $S_{21}$  values enable the measuring errors in  $\epsilon_r$  and  $\mu_r$  to be determined. At the lower end of the frequency range, the permeability accuracy depends on the permittivity values and is better than 10 percent for higher values of  $\epsilon'$  ( $\epsilon' > 5$ ). This accuracy increases with frequency and the sample thickness and is better than 5 percent above 5 GHz. The permittivity accuracy is practically constant and is equal to 2 percent. The uncertainty

for  $\epsilon_r$  and  $\mu_r$  caused by a small error in the physical length of the sample is practically equal to the percentage of the error. As it is easy to measure the sample length to an accuracy within  $\pm 0.01$  mm, the uncertainty due to an error in the length of the sample material is not a main factor for this measurement method.

The permittivity and permeability of the magnetite  $\text{Fe}_3\text{O}_4$  were measured with this technique ( $2d = 1$  mm). The sample is powder compacted at a pressure of 3.5 metric tons for one minute. The measurement results appear in Fig. 9.

## V. CONCLUSION: EXTENDING THE METHOD TO MILLIMETER WAVES

A broad-band technique is presented for simultaneously measuring the real and imaginary parts of both the permittivity and permeability of a given material. The material under test fills a gap in a coaxial line. To avoid contact resistances and contact capacitances, the sample is metalized on the contact surfaces with the line conductors. Required dimensional tolerances are 0.01 mm. The values of  $\epsilon_r$  and  $\mu_r$  are computed from measurements of  $S_{11}$  and  $S_{21}$  made on an automated network analyzer. This method is easy to use and requires no corrections in experimental results. With a single sample, it allows continuous characterization up to 18 GHz. By using APC2.4 millimeter connections, the method can be extended up to 50 GHz. Consequently magnetic materials can be studied at millimeter wavelengths.

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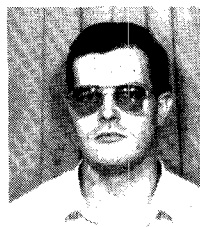
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